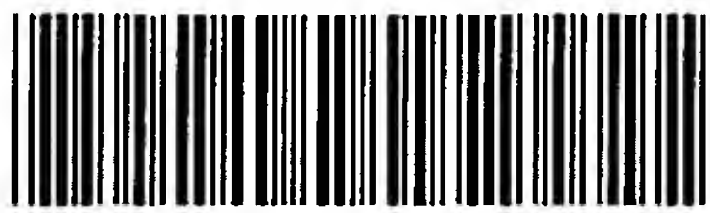


Search Notes



Application/Control No.	Applicant(s)/Patent under Reexamination	
10/604,717	LIU	
Examiner	Art Unit	
Richard H. Kim	2871	

SEARCHED			
Class	Subclass	Date	Examiner

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner

SEARCH NOTES (INCLUDING SEARCH STRATEGY)		
	DATE	EXMR
East Subclass search (349/161; jpo,epo,uspat,pgpub)-see printout	10/3/2005	RHK